

OK TO ENTER: /S.A./
03/18/2010

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 2826
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q81505

Akira BANDOH, et al.

Appln. No.: 10/585,744

Group Art Unit: 2826

Confirmation No.: 1506

Examiner: Selim U AHMED

Filed: July 12, 2006

For: N-TYPE GROUP III NITRIDE SEMICONDUCTOR LAYERED STRUCTURE

RESPONSE UNDER 37 C.F.R. § 1.116

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 30, 2009, please consider the remarks as submitted herewith on the accompanying pages. Since February 28, 2010 fell on a Sunday, the filing of this Response on Monday, March 1, 2010 is timely.

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